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TECHNOLOGY CENTER 2800

PATENT APPLICATION

RESPONSE UNDER 37 CFR §1.116

EXPEDITED PROCEDURE

TECHNOLOGY CENTER ART UNIT 2814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroaki ABE et al.

Application No.: 08/930,449

Filed: October 7, 1997

For: HIGH ENERGY SUPPLY APPARATUS, METHOD OF FORMING CRYSTALLINE  
FILM AND METHOD OF MANUFACTURING THIN FILM ELECTRONIC DEVICE

Group Art Unit: 2814

Examiner: Shrinivas H. Rao

Docket No.: 039514

# 312 Aut

M. Brunson

4/9/03

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

entered  
7/31/03  
april

Sir:

In reply to the March 6, 2003 Office Action, please consider the following:

**Amendments to the claims; and**

**Remarks.**